
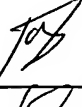
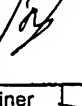



8/1/2003

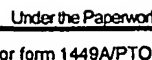
[illegible]

OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)	
	PETER SINGER, Editor-in Chief, August 1, 1999, "Dual-Damascene Challenges Dielectric Etch", <a href="http://www.e-insite.net/semiconductor/index.asp?layout=articlePrint&amp;articleID=CA165320">http://www.e-insite.net/semiconductor/index.asp?layout=articlePrint&amp;articleID=CA165320</a> , last visited 05/29/2003
	"Copper, with and without Damascene", <a href="http://www.semiconductor.net/technical/damascene_copper.htm">http://www.semiconductor.net/technical/damascene_copper.htm</a> , last visited 07/24/2002
	"Etching of Silicon Nitride", Application of Silicon Nitride, <a href="http://courses.nus.edu.sg/course/phyweets/Projects98/etch/si3n4.htm">http://courses.nus.edu.sg/course/phyweets/Projects98/etch/si3n4.htm</a> , last visited 07/23/2002
Examiner Signature	 Date Considered 26 May 2005

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*(Use as many sheets as necessary)*

Sheet	1	of	2
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
**Complete if Known**

<b>Application Number</b>	10/632,873
<b>Filing Date</b>	8/1/2003
<b>First Named Inventor</b>	Kim, et al.
<b>Art Unit</b>	1765
<b>Examiner Name</b>	Not yet assigned
<b>Attorney Docket Number</b>	APPM7354/ETCH/DRIE

## U.S. PATENT DOCUMENTS

[illegible]

## FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T <sup>6</sup>
		Country Code <sup>3</sup> - Number <sup>4</sup> - Kind Code <sup>5</sup> (if known)				
	B1	JP2001127040	11/5/01	Tokyo Electron Limited		X
	B2	EP1059664	12/13/00	Applied Materials		
	B3	WO02/19408	3/7/02	Applied Materials		
	B4	EP1308994	5/7/03	Texas Instruments		
	B5	WO03/081645	10/2/03	Applied Materials		

**Examiner  
Signature**

Date  
Considered

26 May 2005

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Sheet 2

of

2

**Complete if Known**

Application Number 10/632,873

Filing Date 8/1/2003

First Named Inventor Kim, et al.

Art Unit 1765

Examiner Name

Attorney Docket Number APPM/7354/ETCH/DRIE

**NON PATENT LITERATURE DOCUMENTS**

Examiner Initials *	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
	C1	European Search Report for Application 04018095.2-1235, 3/23/2005	
	C2	Morikawa Y, et al: "Control of Surface Reaction on Highly Accurate Low-K Methylsilsesquioxane Etching Process" Japanese Journal of Applied Physics. Tokyo, JP, vol. 42, no. 12A, Part 2, 1 December 2001 (2002-12-01), pages L1406-L1408, XP001164580 ISSN: 00221-4922, page L1407	

Examiner Signature		Date Considered	26 May 2005
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